

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Betelhem Shewareged
KATSUTOSHI MISUDA, ET AL.	)	
	:	Group Art Unit: 1774
Application No.: 10/787,080	)	
	:	Confirmation No.: 4301
Filed: February 27, 2004	)	
	:	
For: RECORDING MEDIUM, IMAGE	)	
FORMING PROCESS USING THE	:	
RECORDING MEDIUM AND	)	
PRODUCTION PROCESS OF THE	:	
RECORDING MEDIUM	)	January 18, 2007

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

STATEMENT OF SUBSTANCE OF INTERVIEW AND  
LETTER TRANSMITTING SWORN TRANSLATION

Sir:

Applicants wish to thank the Examiner for the courtesies extended in granting and conducting on January 12, 2007, a personal interview with Applicants' representative.

During the interview, Applicants' representative and the Examiner discussed the outstanding rejections, which are respectfully traversed. Applicants understand from the interview that the Examiner is in tentative agreement that the rejections would be obviated

upon the filing of a sworn translation of the Alumina Sol 520 datasheet submitted with the December 19, 2006 Information Disclosure Statement. Also, the Examiner suggested a couple of minor translational corrections. In accordance with the foregoing, Applicants are submitting herewith a sworn translation of the datasheet that includes the kind suggestions of the Examiner, together with a new Form PTO-1449 listing said translation. Favorable consideration is earnestly solicited.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

/Daniel S. Glueck/  
Daniel S. Glueck  
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